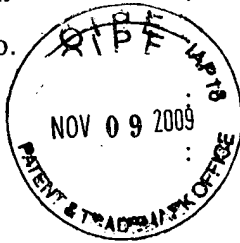


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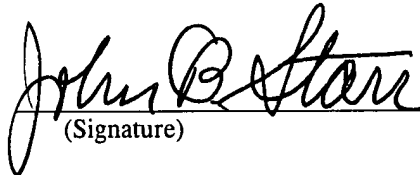
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| | | |
|------------------|---|--|
| Applicant | : | Hideo YOSHIDA, et al. |
| Serial No. | : | 10/526,205 |
| Filed | : | March 1, 2005 |
| For | : | ANODIC OXIDATION METHOD, TITANIUM OXIDE FILM MANUFACTURING METHOD AND CATALYST CARRYING METHOD |
| Group Art Unit | : | 1795 |
| Examiner | : | William T. Leader |
| Confirmation No. | : | 4976 |
| Customer No. | : | 000028107 |

Certificate of Mailing Under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450 on November 6, 2009.

John B. Starr, Jr., Ph.D
(Name)


(Signature)

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY and AMENDMENT UNDER 37 C.F.R. § 1.111

Sir:

Responsive to the Office Action mailed 06 August 2009, the present paper is timely filed on or before 06 November 2009. Please amend the Application as follows.

11/10/2009 LLANDGRA 00000053 10526205

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